

Area Representative:

**Bud Rogers**

**(214) 592-0039**

bud-rogers@tx.rr.com

# Remote Plasma Cleaning

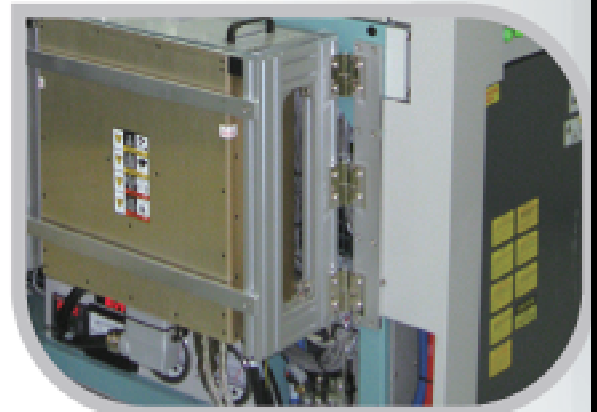
[www.WetBenches.net](http://www.WetBenches.net)

**SYSTA provides FAB proven RPC products for most Thin Film tools. Our RPC solutions come with professional installation and a full warranty.**



Images showing  
RPC deployed  
on Novellus C2

View of Reactor



View of Generator

RPC solutions available for most OEM brands and models !

## End users report a reasonably quick ROI:

- Up to 30% increase in throughput
- Clean Times reduced by 2X - 5X
- Up to 3X increase in the time interval between PMs
- Cost savings from improved lifetime of chamber parts
- Improved particle performance
- Eliminate 1st wafer after clean thickness variation

**Ask to see the data!**

***RPC is now widely accepted as the leading chamber cleaning BKM by both users & OEMs.***

**C2F6 chamber cleaning accounts for 50%-70% of the PFCs used in semiconductor fabrication. NF3 RPC reduces global warming emissions by ~95%**